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Applicant: Hiroshi KAJIYAMA, et al.

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Group

INFORMATION DISCLOSURE STATEMENT
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U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date (if appropriate)
	AA						
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FOREIGN PATENT DOCUMENTS								
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	TRANSLATION	
							Yes	No
	AK							
	AL							
	AM							
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	AO							
	AP							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
D.D.	AQ	WATANABE, et al. "MgO Material used as protective Layer for PDP (Plasma Display Panels)" Monthly Journal, February 2000					
D.D.	AR	UETANI, et al. "Ion-Plating Desposition of MgO Thin Films" Materials Transactions, 2001					
D.D.	AS	UETANI, et al. "Ion-Plating Deposition of MgO Protective Layer for AC-Plasma Display Panels" Materials Research Society, 2001					
D.D.	AT	UETANI, et al. "Secondary Electron Emission Characteristics of MgO Thin Films Prepared by an Advanced Ion-Plating Method" Materials Transactions, 2001					

EXAMINER *[Signature]*

DATE CONSIDERED 12/19/02

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication.